

# Physical and Sensing Properties of Aluminum-Doped Iron (III) Oxide Thin Films Deposited via Chemical Spray Pyrolysis

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**Keywords:** Aluminum-Doped Iron Oxide, Thin Film, CSP, XRD, AFM, Optical Properties, Sensitivity and Resistance.

**Abstract:** Fe<sub>2</sub>O<sub>3</sub>:Al (1–3 at%) thin films were successfully grown on glass substrates at 400°C using the chemical spray pyrolysis (CSP) technique. The X-ray diffraction (XRD) patterns confirmed the formation of  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> with a prominent (104) peak, indicating high crystallinity. The average grain size (D) increased from 15.82 nm to 18.70 nm with increasing Al content, while the lattice strain ( $\epsilon$ ) decreased from 2.18 to 1.85, suggesting improved crystal quality. Atomic Force Microscopy (AFM) analysis showed a reduction in surface roughness and uniform particle distribution, with particle diameters ranging from 65.5 nm to 52.31 nm. Optical studies revealed a gradual narrowing of the bandgap values from 2.81 eV (undoped) to 2.74 eV, 2.69 eV, and 2.64 eV for 0 at%, 1 at%, and 3 at% Al-doping levels, respectively. Furthermore, gas sensing tests demonstrated that higher Al doping increased resistance and reduced sensitivity toward NO<sub>2</sub> gas due to enhanced charge carrier recombination and altered surface interactions, indicating significant influence on semiconductor gas sensing properties.

## 1 INTRODUCTION

Iron oxide thin films (Fe<sub>2</sub>O<sub>3</sub>) doped with Al (1–3 at%) were successfully deposited on glass substrates at 400 °C using the chemical spray pyrolysis (CSP) technique [1], [2] - [5]. Iron oxides exist in different stoichiometries and crystalline forms, including FeO, Fe<sub>3</sub>O<sub>4</sub>,  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>, and  $\gamma$ -Fe<sub>2</sub>O<sub>3</sub>, with hematite ( $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>) being the most stable phase [6] - [9]. Its favorable properties such as non-toxicity, low cost, and wide availability make it highly suitable for numerous applications [10] - [12].

The structural analysis by X-ray diffraction (XRD) confirmed the formation of  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> with a dominant (104) reflection, indicating high crystallinity. The average crystallite size increased from 15.82 nm to 18.70 nm with rising Al concentration, while the lattice strain decreased from 2.18 to 1.85, suggesting improved crystal quality. Atomic force microscopy (AFM) revealed a

reduction in surface roughness and a more uniform particle distribution, with average particle sizes ranging from 65.5 nm to 52.31 nm.

Optical characterization showed a progressive narrowing of the optical bandgap from 2.81 eV (undoped) to 2.74 eV, 2.69 eV, and 2.64 eV for 0 at%, 1 at%, and 3 at% Al doping, respectively [19], [20]. Since the ionic radii of Al<sup>3+</sup> (0.675 Å) and Fe<sup>3+</sup> (0.69 Å) are close, partial substitution of Fe<sup>3+</sup> by Al<sup>3+</sup> is expected, influencing both the structural and optical properties of the films.

Gas sensing studies demonstrated that higher Al doping increased electrical resistance and reduced sensitivity toward NO<sub>2</sub> due to enhanced charge carrier recombination and modified surface interactions [10] - [14]. While various preparation techniques such as sol-gel [15], electrodeposition [16], sonochemical methods [17], and electrospinning [18] have also been employed for Fe<sub>2</sub>O<sub>3</sub> films [19] - [22], CSP remains an efficient and attractive approach for large-

area deposition and detailed characterization [23], [21] - [24].

## 2 EXPERIMENTAL

Thin films of  $\text{Fe}_2\text{O}_3$ : Al is prepared by (CSP) technique. 0.1 M of both  $\text{AlCl}_3$  and  $\text{FeCl}_3$  diluted with redistilled. Al 1% and 3% was utilized. The deposition circumstances were: spray time 8 s and then stopped 1 min. The carrier gas used was air, with a pressure of  $10^5$  Pa, and the distance between the spout and the base was  $28 \text{ cm} \pm 1 \text{ cm}$ . Film thickness was found to be  $325 \pm 30 \text{ nm}$ . XRD analysis verified the formation of a  $\text{Fe}_2\text{O}_3$  thin film, and AFM is used to determine film shape. Transmittance was done via a spectrophotometer. Undoped and Al-doped  $\text{Fe}_2\text{O}_3$  gas sensors were tested for sensitivity by resistance change in a  $7.5 \times 15 \text{ cm}$  cylindrical chamber.

## 3 RESULTS AND DISCUSSION

XRD spectra of  $\text{Fe}_2\text{O}_3$ :Al films are displayed in Figure 1. ICDD card no. 40-1139 and 39-1364 was fitted with the obtained data. Diffraction peaks correspond to (221), (104) and (116) planes. The shift in peak position is that the ionic radius of  $\text{Al}^{3+}$  is less than that of  $\text{Fe}^{3+}$  ( $0.53 \text{ \AA}$  compared to  $0.69 \text{ \AA}$ ) [25]. The sharp and intense diffraction peaks are clearly indexed to the  $\alpha\text{-Fe}_2\text{O}_3$  crystalline phase.

The average crystallite size ( $D$ ) is offered via Scherrer (1) [26]:

$$D = \frac{0.9\lambda}{\beta \cos \theta} \quad (1)$$

Where  $\theta$  is Bragg angle,  $\beta$  is FWHM, and  $\lambda$  is X-ray wavelength.  $D$  are in range of 15–18 nm. The strain  $\varepsilon$  is obtained by utilizing the following by (2) [27]:

$$\varepsilon = \frac{\beta \cos \theta}{4} \quad (2)$$

The dislocation density  $\delta$  is obtained by the following relation [28]

$$\delta = \frac{1}{D^2} \quad (3)$$

It is mentioned that as Al content increases,  $\delta$  and  $\varepsilon$  decrease and is assigned to the variation in ionic radii of  $\text{Al}^{3+}$  and  $\text{Fe}^{3+}$  as shown in Figure 2 c and d. the crystallite size is decreased; however, after doping, there is large crystallites that agree with [30], [32]. The values for  $D$  and  $\varepsilon$  are given in Table 1. A slight increase in  $D$  and a decrease in  $\varepsilon$ . These results agree with [33], [34]. The structural parameters are calculated and listed in Table 1.

AFM images of the grown films are offered in Figure 3, offering films uniformity. The Average Particle size  $P_{av}$  is seen as 65.5 nm, 58.7 nm and 52.3 nm for the concentration of 0%, 1% and 3%, respectively. Generally, the roughness  $R_a$  of films in the area of 8.4-4.8 nm. The undoped film surface exhibits a larger root-mean-square (rms) roughness of 9.4 nm. However, rms and  $R_a$  decrease is seen for 1% and 3% Al. Similar result is noticed in [35], [36]. The summary of the surface topography  $S_T$  is shown in Table 2.

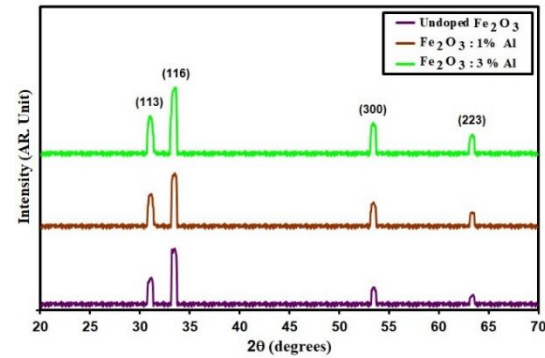


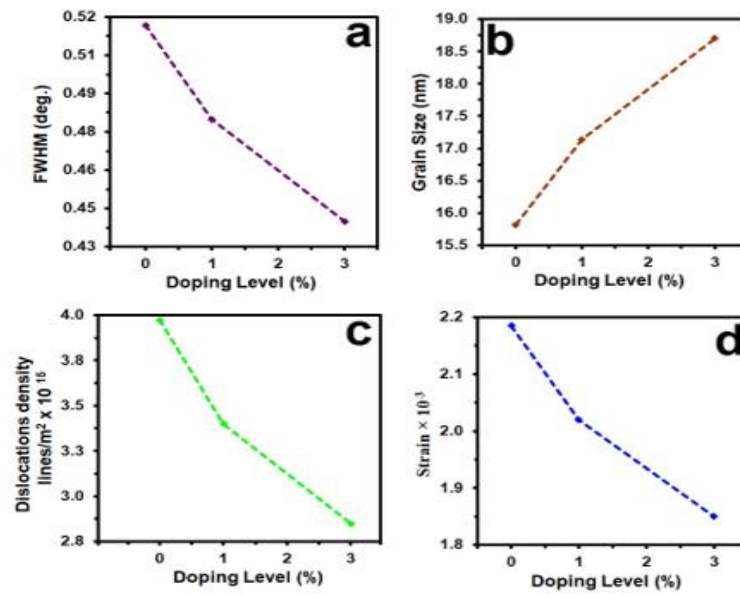
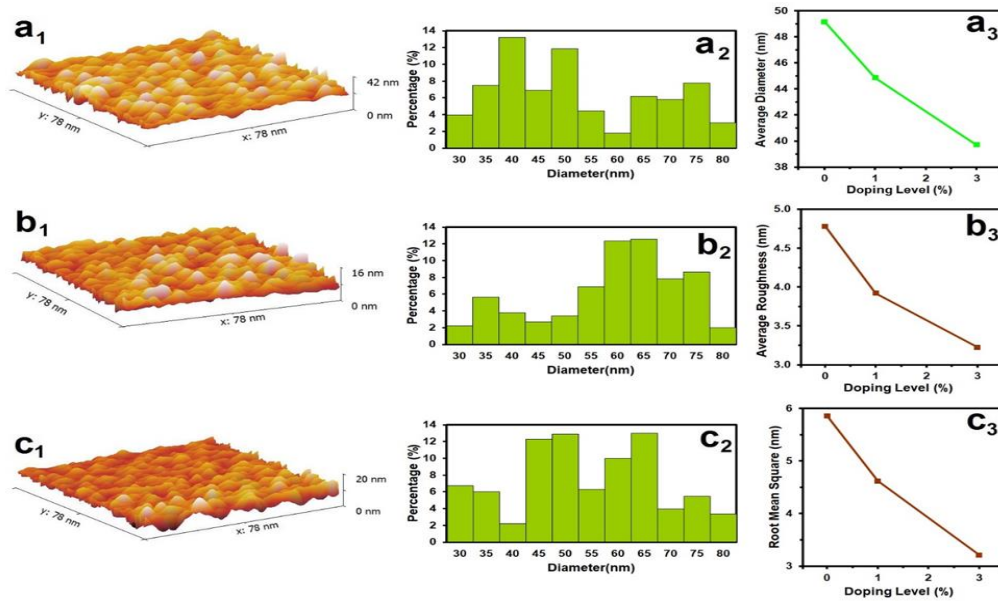
Figure 1: XRD patterns of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

Table 1: Structure parameters of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

| Samples                         | (hkl) Plane | $2\theta$ (°) | FWHM (°) | $E_g$ eV | $D$ nm | $\delta$ $\times 10^{15}$ (line/m <sup>2</sup> ) | $\varepsilon$ ( $\times 10^{-3}$ ) |
|---------------------------------|-------------|---------------|----------|----------|--------|--|------------------------------------|
| Undoped $\text{Fe}_2\text{O}_3$ | 104         | 33.82         | 0.51     | 2.74     | 15.8   | 3.9  | 2.1                                |
| $\text{Fe}_2\text{O}_3$ : 1% Al | 104         | 33.79         | 0.48     | 0.69     | 17.1   | 3.4  | 2.0                                |
| $\text{Fe}_2\text{O}_3$ : 3% Al | 104         | 33.74         | 0.44     | 2.64     | 18.7   | 2.8  | 1.8                                |

Table 2: The Morphological values of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

| Samples                         | $P_{av}$ , nm | $R_a$ , nm | $R_{ms}$ , nm |
|---------------------------------|---------------|------------|---------------|
| Undoped $\text{Fe}_2\text{O}_3$ | 65.5          | 8.7        | 9.4           |
| $\text{Fe}_2\text{O}_3$ : 1% Al | 58.7          | 6.3        | 8.7           |
| $\text{Fe}_2\text{O}_3$ : 3% Al | 52.3          | 4.8        | 5.4           |


 Figure 2: X-ray parameter of Undoped and Fe<sub>2</sub>O<sub>3</sub>: Al films.

 Figure 3: AFM images of Undoped and Fe<sub>2</sub>O<sub>3</sub>: Al films.

The transmittance  $T$  of the intended films is displayed in Figure 4. Films have a transparency of 65 %. From Figure 4. The doping decreases  $T$ , which refers to strong scattering and absorption [37], [38]. The drop in  $T$  with increasing Al content can be assigned to the surrogate of Fe<sup>+3</sup> by Al<sup>+3</sup>, which reduces light in the  $T$  band. This behavior is similar to that observed in [39], [40].

The absorption coefficient ( $\alpha$ ) was evaluated using the optical transmittance spectra.  $\alpha$  is calculated using (4) [41]:

$$\alpha = \frac{1}{d} \ln \frac{I_0}{I} = 2.303 \left( \frac{A}{d} \right), \quad (4)$$

where  $d$  is film thickness. Figure 5 shows  $\alpha$  versus the photon energy ( $h\nu$ ) of various doping of Al. High

$\alpha$  between  $1 \times 10^4 \text{ cm}^{-1}$  and  $6 \times 10^4 \text{ cm}^{-1}$  in the visible area. Also, we note that the  $\alpha$  increased with film doping increasing.

Optical bandgap, denoted by (5) is computed employing the relation below [42]:

$$(\alpha h\nu) = A(h\nu - E_g)^n, \quad (5)$$

where A is constant and  $n = \frac{1}{2}$ , for allowed direct transitions. Figure 6. shows  $E_g$  values determined as 2.74, 2.69 and 2.64, 2.81 at 0.at%, 1 at% and 3 at% of Al respectively. This decrease in bandgap indicates that Al provides  $\text{Al}^{3+}$  ions [43], [44].

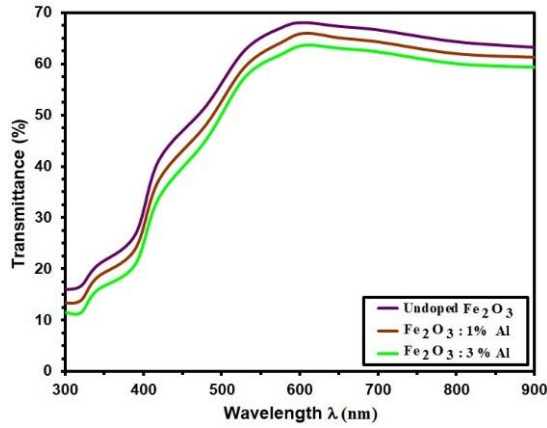


Figure 4: Transmittance of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

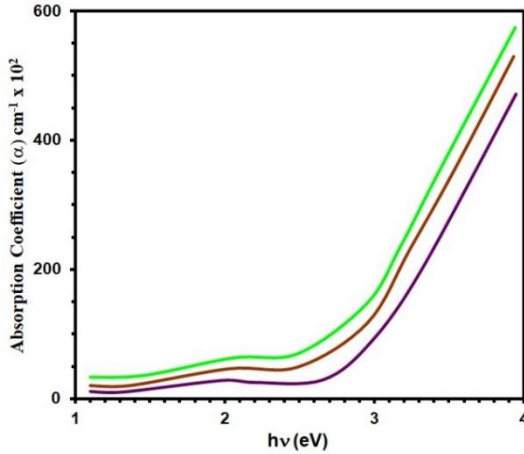


Figure 5: Absorption coefficient ( $\alpha$ ) of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

The formula below [36] evaluates the extinction coefficient ( $k$ ) [45, 46]:

$$k = \frac{\alpha \lambda}{4\pi}. \quad (6)$$

$k$  against wavelength is shown in Figure 7. There is a decrease  $k$  in the visible area of 550-700 nm, then a rapid rise within the 400-500 nm area.  $k$  increasing with Al content and arriving at the highest value at 3wt% content, this increase is related to an increase in carrier concentration in CB according to Burstein-Moss effect [47], [48].

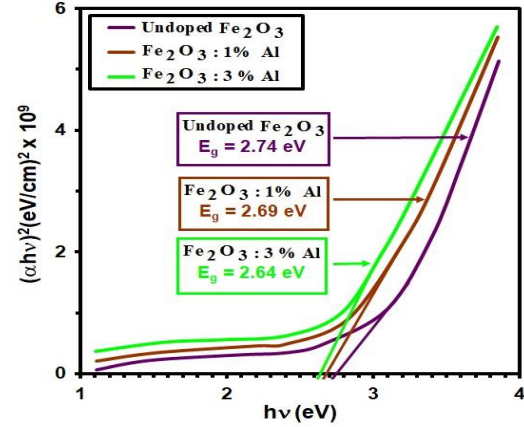


Figure 6: Optical bandgap ( $E_g$ ) of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films

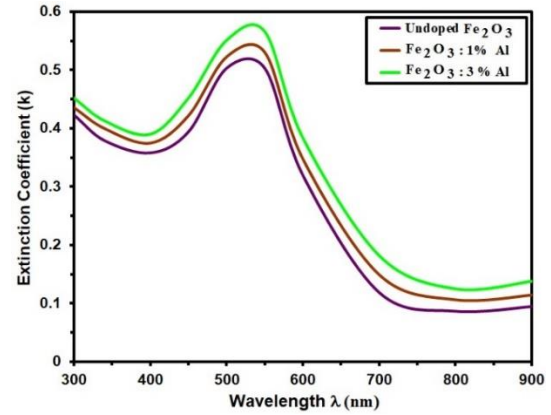


Figure 7: Extinction coefficient ( $k$ ) of Undoped and  $\text{Fe}_2\text{O}_3$ : Al films.

The refractive index ( $n$ ) is obtained by the relation [49]:

$$n = \frac{1+R^2}{1-R^2} \quad (7)$$

Figure 8 offers  $n$  plotted via wavelength. The values  $n$  is in the area of 3.5–3.75 and are almost constant at longer wavelengths. It can be assigned to film polarization [40], [51]. These results assure using this composite as a window layer of solar cell [52], [53].

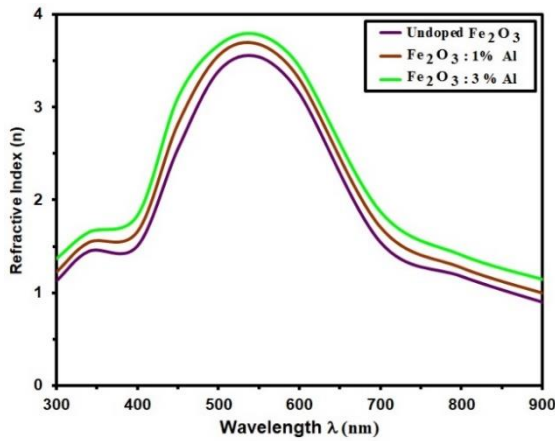


Figure 8: Refractive index (n) of Undoped and Fe<sub>2</sub>O<sub>3</sub>: Al films.

Figure 9 shows increased resistance over time for undoped and Al-doped Fe<sub>2</sub>O<sub>3</sub> films exposed to 300 ppm NO<sub>2</sub> at 150 °C, indicating surface oxidation during gas exposure [54], [55]. NO<sub>2</sub> adsorption on Fe<sub>2</sub>O<sub>3</sub> films removes O<sub>2</sub><sup>+</sup> ions, releasing electrons to the conduction band and increasing resistance. Al doping, especially at 4%, significantly enhances resistance, demonstrating its strong effect on sensing and semiconductor properties[56] - [58].

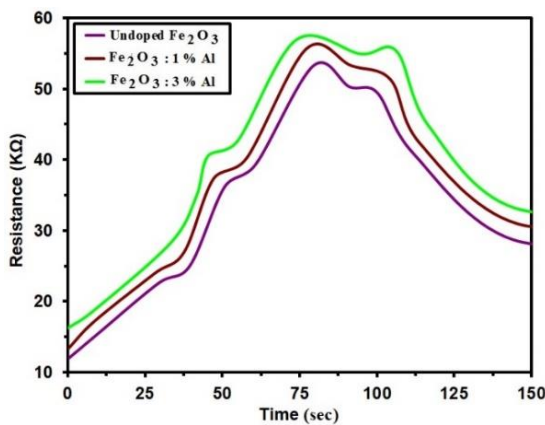


Figure 9: The variation of resistance over time for Fe<sub>2</sub>O<sub>3</sub> and Al-doped Fe<sub>2</sub>O<sub>3</sub> films.

Sensitivity (S) is calculated using the following (8) [59]:

$$Sensitivity = \frac{\Delta R}{R_g} = \left| \frac{R_g - R_a}{R_g} \right| \times 100 \% . \quad (8)$$

Figure 10 shows reduced sensitivity with higher Al content due to increased resistance from charge carrier recombination after NO<sub>2</sub> exposure. Increasing Al doping leads to greater charge carrier

recombination, reducing conductivity and gas response [60]. Sensitivity drops significantly at higher doping levels, indicating suppressed NO<sub>2</sub> sensing performance of Fe<sub>2</sub>O<sub>3</sub> films due to reduced free carrier availability [61].

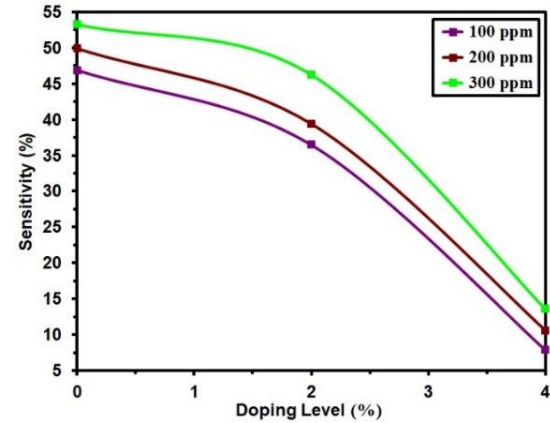


Figure 10: Sensitivity (S) as a function of Al-doped Fe<sub>2</sub>O<sub>3</sub> films at different concentrations.

## 4 CONCLUSIONS

Aluminum-doped iron oxide (Fe<sub>2</sub>O<sub>3</sub>:Al) thin films were successfully synthesized using the chemical spray pyrolysis (CSP) technique at a substrate temperature of 400°C. Structural analysis confirmed the formation of a well-crystallized α-Fe<sub>2</sub>O<sub>3</sub> phase across all doping levels, with enhanced crystallinity observed at 3 at% Al. The incorporation of Al<sup>3+</sup> ions led to a slight increase in crystallite size and a reduction in lattice strain and dislocation density. Morphological analysis revealed that increasing Al content resulted in more uniform surface morphology, reduced particle size, and lower surface roughness, as confirmed by AFM measurements. These improvements are beneficial for optical and electronic applications. Optical characterization showed that the transmittance and optical bandgap (E<sub>g</sub>) decreased with increasing Al doping, while the extinction coefficient (k) and refractive index (n) increased. The bandgap narrowing is attributed to enhanced carrier concentration and Al<sup>3+</sup> substitution effect. Gas sensing performance tests indicated that while Al doping improved film crystallinity and morphology, it adversely affected sensitivity to NO<sub>2</sub> gas. Higher Al concentrations led to increased resistance and suppressed sensor response due to enhanced charge carrier recombination and reduced availability of free carriers.

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